**PATENT** 

## UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of: Joseph T. Pesik		)	
11	•	)	Examiner: E. Cherry
Serial No.:	10/611,631	)	Art Unit: 2872
Filed:	July 1, 2003	)	
For: SILIC	CON WAFER BASED MACRO-	)	Atty. Docket Nos.: 21220/04152 (201AS407A)
SCOPIC MIRROR FOR WIDE ANGLE		)	(=====,
SCA	NNING APPLICATIONS	)	

## **SUBMISSION OF REPLACEMENT DRAWINGS**

Commissioner for Patents P. O. Box 1450 Alexandria, VA 22313-1450

## Gentlemen:

Please substitute the drawings filed on July 1, 2003 with the attached replacement drawings (4 sheets).

Please charge the Deposit Account No. <u>03-0172</u> for any fees related to the acceptance of the attached Replacement Drawings.

Respectfully submitted,

y: 3 (sndis) Brian E. Kondas, Reg. No. 40,685

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